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Rec. No.: EV 332 276 739 US  
On: JULY 16, 2003  
By: *Linda E. Hastings*  
LINDA E. HASTINGS  
Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

**ATTORNEY DOCKET NO. NECK 17.552**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Hiroshi TANABE  
Serial No.: 09/614,286 ✓  
Filed: July 12, 2000  
Title: METHOD FOR FORMING SEMICONDUCTOR FILMS  
AT DESIRED POSITIONS ON A SUBSTRATE  
Examiner: Timothy J. Sutton  
Group Art Unit: 2813  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

RECEIVED  
JUL 21 2003  
TECHNOLOGY CENTER 2800

**RESPONSE TO OFFICE ACTION**

Sir:

In response to the Office Action mailed on April 17, 2003, the period for responding thereto expiring after July 17, 2003, please amend the subject application as follows: